

RECEIVED
CENTRAL FAX CENTER

MARSHALL, GERSTEIN & BORUN LLP
ATTORNEYS AT LAW
6300 SEARS TOWER
233 SOUTH WACKER DRIVE
CHICAGO, ILLINOIS 60606-6357
(312) 474-6300
FAX: (312) 474-0448

OCT 19 2006

10/19/2006

FACSIMILE TRANSMISSION SHEET

TO: United States Patent and
Trademark Office

+1 (571) 273-8300

FROM: Richard H. Anderson

RE: U.S. Patent Application No. 10/749,022

PAGES (INCLUDING THIS PAGE): 7

If you do not receive all pages of this fax in good condition, please contact Delaunda Collier at (312) 474-6300.

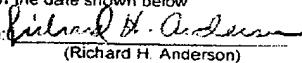
This transmission contains confidential information intended only for the addressee. If you are not the addressee, any disclosure or use of this information by you is strictly prohibited. If you have received this facsimile in error, please notify us by telephone immediately.

RECEIVED
CENTRAL FAX CENTER

OCT 19 2006

Docket No.: 29936/39889
(PATENT)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted by facsimile to the Patent and Trademark Office, facsimile no. (571) 273-8300, on the date shown below

Dated: October 19, 2006 Signature: 
(Richard H. Anderson)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Sang K. Park

Application No.: 10/749,022

Confirmation No.: 9225

Filed: December 30, 2003

Art Unit: 2812

For: **METHOD OF FORMING COPPER WIRING IN
SEMICONDUCTOR DEVICE**

Examiner: M. Ahmadi

AMENDMENT

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

Please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.